



<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT PTO-1449</b>	Docket No. <b>52433/820</b>	Application No. <b>10/551,159</b>
	Applicant(s) <b>Koki TONAKA et al.</b>	Examiner <b>John J. Zimmerman</b>
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		Art Unit <b>1794</b>

**U. S. PATENT DOCUMENTS**

EXAMINER INITIAL	PATENT/PUBLICATION NUMBER	PATENT/PUBLICATION DATE mm/dd/yyyy	NAME	CLASS	SUBCLASS	FILING DATE

**FOREIGN PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER	DATE mm/dd/yyyy	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						Yes	No
	JP 2001-200352	07/24/2001	JP			Abstract	
	JP 2001-288550	10/19/2001	JP			Abstract	
	JP 2001-279412	10/10/2001	JP			Abstract	
	JP 2004-204280	07/22/2004	JP			Abstract	

**OTHER DOCUMENTS**

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
	Japanese Office Action dated March 23, 2009 issued in corresponding Japanese Application No. 2004-027623
	Japanese Office Action dated December 28, 2008 issued in corresponding Japanese Application No. 2004-027623
	Yanagihara et al., "MATERIA JAPAN" The Japan Institute of Metals, Vol. 39, No. 5 (2000), pgs. 450-455

EXAMINER	DATE CONSIDERED
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	